

TRANSMITTAL

Electronic Version v1.1

Stylesheet Version v1.1.0

Title of Invention	[SEMICONDUCTOR STRUCTURE AND FABRICATION THEREFOR]							
Application Number :								
Date :								
First Named Applicant:	Mr. Yi-Ching Wu							
Confirmation Number:								
Attorney Docket Number:	13302-US-PA							
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<table><tr><td>Submitted By:</td><td>Elec. Sign.</td><td>Sign. Capacity</td></tr><tr><td>Dr. Belinda Lee Registered Number: 46863</td><td>/Belinda Lee/</td><td>Agent</td></tr></table>			Submitted By:	Elec. Sign.	Sign. Capacity	Dr. Belinda Lee Registered Number: 46863	/Belinda Lee/	Agent
Submitted By:	Elec. Sign.	Sign. Capacity						
Dr. Belinda Lee Registered Number: 46863	/Belinda Lee/	Agent						

Documents being submitted:	Files
us-fee-sheet	13302-usfees.xml us-fee-sheet.xsl us-fee-sheet.dtd
us-request	13302-usrequ.xml us-request.dtd us-request.xsl
us-assignment	13302-usassn.xml us-assignment.xsl us-assignment.dtd 13302assignment01.tif 13302assignment02.tif
us-declaration	13302declaration01.tif
us-declaration	13302declaration02.tif
application-body	13302-trans.xml us-application-body.xsl application-body.dtd wipo.ent mathml2.dtd mathml2-qname-1.mod isoamsa.ent isoamsb.ent isoamsc.ent isoamsn.ent isoamso.ent isoamsr.ent isogr3.ent isomfrk.ent isomopf.ent isomscr.ent isotech.ent isobox.ent isocyr1.ent isocyr2.ent isodia.ent isolat1.ent isolat2.ent isonum.ent isopub.ent mmlextra.ent mmlalias.ent soextblx.dtd 13302US0001.tif 13302US0002.tif 13302US0003.tif 13302US0004.tif
Comments Please be kindly advised that the indicated fees of this EFS application is intended to be paid by credit card. However, in the event that the payment through credit card is unsuccessful, the Commissioner is authorized to charge the required fees in connection with this application to: Deposit Account No. 50-2620 (Order No. 13302-US-PA), Deposit Account Name: Jianq Chyun Intellectual Property Office, Authorized User Name:	

